# Test Results of TTF-V Couplers for ILC

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# Context of the Input Power Coupler Activities @ LAL

Design and test of alternative Power Coupler Prototypes for ILC

- □ Close collaboration with DESY on Power Coupler R&D and XFEL Coupler Industrialization Studies
- The support of the European Community-Research Infrastructure Activity under the FP6 "Structuring the European Research Area" program (CARE).
- Collaboration with KEK on "R&D on High Power Couplers for the ILC» in the framework of the FJPPL

In this framework TTF-V couplers have been :

Designed:

- Based on the TTF-III Coupler Design (Baseline ILC Power Coupler)
- Design performed by Pierre LEPERCQ (LAL)
- Then RF power tested

# **TTF-V Coupler Prototype**

Pierre Lepercq RF Studies (LAL)



- TTF-V is very similar to TTF-III, but, have larger cold part diameter in order to shift multipacting to higher power levels\*.
- TTF-V design have been simplified:
  - No bellows in the cold part (fixed antenna penetration)
  - Thermal design is not totally optimized

\*Multipacting scaling law in coaxial lines:

 $P_{1-point} \sim (f \cdot D)^4 \cdot Z$ 

 $P_{2\text{-point}} \simeq (f \cdot D)^4 \cdot Z^2$ 

### **Main Stages**

- □ 2 pairs of TTF-V manufactured by ACCEL
- New test box designed (LAL) then manufactured by the same manufacturer
- □ All TTF-V Couplers cleaned using the TTF-III cleaning procedure.
- □ First Coupler pair RF Power tested @ LAL
  - The goal : RF conditioning using the TTF-III conditioning procedure (**1 MW** for short pulses & 0.5 MW for 1.3 ms pulses)
- □ Second Coupler pair RF Power tested @KEK

The goal:

- RF conditioning using the TTF-III conditioning procedure
- Then RF conditioning using ILC Power Couplers RF conditioning procedure @ KEK (2 MW for short pulses & 1 MW for 1.5 ms pulses)



TTF-V Power Coupler pair

### **RF Design**



#### Low Level RF Measurements

Frequency (GHz)

Good Low Level RF measurement results obtained for the two coupler pairs

S11 Low level RF measurements -5 **-** S22 (First TTF-V pair) S12 -10 S21 -15 -20 (dB) -25 -30 dB -30 35 dB 1.3 GHz 290E+09 1.292E+09 1.294E+09 1.296E+09 1.298E+09 1.300E+09 1.302E+09 1.304E+09 1.306E+09 1.308E+09 1.310E+09 🕂 S11 + S22 -10 Low level RF measurements .15 ( Second TTF-V pair) -20 -25 -30 -30 dB -35 dB -35 6 3 GHz 40

1,280E+09 1,284E+09 1,288E+09 1,292E+09 1,296E+09 1,300E+09 1,304E+09 1,308E+09 1,312E+09 1,316E+09 1,320E+09

### TTF-V RF Conditioning @ LAL (1)

Use of the TTF-III conditioning procedure: Goal: To reach 1 MW for 400  $\mu$ s pulses and 0.5 MW for 1300  $\mu$ s pulses (as for TTF-III couplers).



TTF-V RF Conditioning @ LAL (2)



Easy conditioning in 24 h only

# TTF-V RF Conditioning @ KEK (1)





January, 2009 Assembly in clean room ; pumping ports & vacuum gauges ↓ Baking at 130°C for 60 h ↓ Set-up of High Power Test Stand



 Step 1 : Target for XFEL (Feb. 2009)

 400 μs, 1.0 MW

 1.5 ms, 0.5 MW, 5 Hz

 Step 2 : Target for ILC (Mar. 2009)

 400 μs, 2.0 MW, 5 Hz

 Step 3 : Target for ILC (May. 2009)

 1.5 ms, 1.0 MW, 5 Hz

From E. KAKO presentation SRF 2009

#### TTF-V RF Conditioning @ KEK (2)



#### TTF-V RF Conditioning @ KEK (3)



From E. KAKO presentation SRF 2009

#### TTF-V RF Conditioning @ KEK (4) Step 3; Target for ILC (May, 2009) 1.0 MW / 1.5 ms, 5 Hz 1.3 ms, 1 Hz 1.3 ms, 5 Hz 1500 50 μs 200 μs 20 μs 100 μs 40 800 µs RF Power [kW] 10 µs 1.5 m/s, 1 Hz 400 µs 5 Hz 1000 1.5 ms, 5 Hz 500 1.0 MW 00<sup>--</sup> 10<sup>-3</sup> 5 10 15 20 25 Vac. Press. [Pa] Vacuum Pressure (Cold) [Pa] Vacuum Pressure (Warm) [Pa] **10**<sup>-4</sup> **10**<sup>-5</sup> -6 10<sup>-</sup> 5 15 20 25 10 0 Time [hours]

From E. KAKO presentation SRF 2009

# Summary

- □ TTF-V Coupler have been deigned as an alternative Power Coupler for ILC
- □ Four TTF-V Couplers and a new Test Box were manufactured
- □ The first pair of the TTF-V was successfully RF power test @ LAL following the TTF-III conditioning procedure: Conditioning time was about 24h (Comparable to the XFEL Couplers RF conditioning time)
- □ The second pair of the TTF-V was RF Power processed @ KEK following the TTF-III procedure, then, the ILC RF conditioning procedure:

The following RF power levels have been reached:

- 2 MW/ 400μs / 5Hz - 1 MW/ 1500 μs / 5Hz

□ Perspectives: Further thermal studies are needed for the TTF-V couplers.

#### Acknowledgment

Thanks to S. Cavalier, T. Chabaud, L. Grandsire, T. Garvey, W. Kaabi, M. Lacroix, P. Lepercq, B. Mercier, M. Omeich, C. Prévost, Yann Peinaud, A. Thiebault, A. Variola and J. Vieira for their contribution to this work.

Thanks to our DESY colleagues

Thanks to our KEK colleagues, especially, E. KAKO

We acknowledge the support of the European Community-Research Infrastructure Activity under the FP6 "Structuring the European Research Area" program (CARE, Contract no. RII3-CT-2003-506395).